

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. ....09/847,165  
 Confirmation No. ....5640  
 Filing Date ..... May 1, 2001  
 Inventor.....David A. Atkinson, et al.  
 Assignee.....BechtelBWXT Idaho, LLC  
 Group Art Unit.....2881  
 Examiner .....Gurzo, Paul M.  
 Attorney's Docket No. ....LIT-PI-355  
 Customer No. ....21567  
 Title: Simultaneous Vaporization and Ionization Source for Particulate Matter Analysis by  
 Ion Mobility Spectrometry and Atmospheric Pressure Ionization Mass Spectrometry

**STATEMENT OF THE SUBSTANCE OF SEPTEMBER 17, 2003 INTERVIEW**

On September 17, 2003, an interview was conducted by telephone concerning the above referenced application. Participants of the interview were Examiner Paul M. Gurzo and Robert C. Hyta. The interview did not include any exhibits or demonstrations. In response to the Office communication dated July 11, 2003, I, Robert C. Hyta, do hereby set forth the substance of such interview.

The interview was initiated by Robert C. Hyta. It was concluded that ion chamber 11 of the Lewis reference does not include a reference device and a conductive conduit.

Respectfully submitted,

Dated: 10/5/03

By: [Signature]

Robert C. Hyta  
 Reg. No. 46,791